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2826

PATENT
(5298-08000/PM01040)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Ramkumar

Serial No. 10/074,884

Filed: February 13, 2002

For: SEMICONDUCTOR TOPOGRAPHY
INCLUDING A THIN OXIDE-NITRIDE
STACK AND METHOD FOR MAKING
THE SAME

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Group Art Unit: 2826
Examiner: Erdem, Fazli.

Atty. Dkt. No. 5298-08000

I hereby certify that this correspondence is being deposited
with the U.S. Postal Service with sufficient postage as First Class
Mail in an envelope addressed to: **Box: Non-Fee Amendment,**
Commissioner for Patents, Washington, D.C. 20231, on the date
indicated below:

September 18, 2003
Date

Kevin L. Daffer

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED JUNE 18, 2003

Box: Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed June 18, 2003 to further highlight reasons why the application is in condition for allowance.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

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